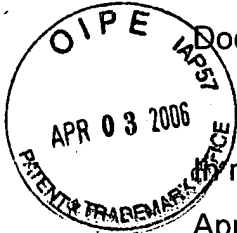


JPW



Docket No. EATNP160US

03-IMP-035

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Re **PATENT** application of:

Applicant: Mehran Asdigha et al.  
Application No.: 10/840,186  
For: MECHANICAL OSCILLATOR FOR WAFER SCAN WITH SPOT BEAM  
Filing Date: May 6, 2004  
Examiner: David A. Vanore  
Art Unit: 2881

**REPLY TO OFFICE ACTION DATED FEBRUARY 1, 2006**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following remarks.